What is claimed is:

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1	1. An	etch/strip	apparatus	integrated	with	cleaning	equipment
2	comprising:						

- an etching line for etching and cleaning a substrate; 3
- a stripping line for stripping the substrate; and 4
- a cleaning line installed on the stripping line to clean and dry the 5 substrate. 6
 - 2. The apparatus as claimed in claim 1, further comprising: an elevator for conveying the substrate from the stripping line to the cleaning line.
 - 3. The apparatus as claimed in claim 1, further comprising:
 - a transfer for moving the substrate from the etching line to the stripping line.
- 4. The apparatus as claimed in claim 1, further comprising: 1 a loader for feeding the substrate to the etching line; and 2 a unloader for receiving the substrate from the cleaning line. 3
- 5. The apparatus as claimed in claim 1, wherein the etching line 1 includes: 2
- an etch module for etching the substrate from the loader; and 3 a rinse module for cleaning the substrate fed from the etch module. 4

- 6. An integrated etch/strip/clean apparatus, comprising:
 an etching line for etching and cleaning a substrate;
- a stripping line for stripping said substrate; and

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- a cleaning line integrated with said etching and stripping lines to clean and dry the substrate.
- 7. The apparatus of claim 6, wherein said cleaning line is installed on said stripping line.
- 8. The apparatus of claim 6, wherein said etching line includes:
 an etch module; and
 a rinse module connected to said etch module.
 - 9. The apparatus of claim 6, further comprising: a transfer module to transfer said substrate from said etching line to said stripping line.
 - 10. The apparatus of claim 9, wherein said transfer module includes:
 2 a pipe shower.
 - 1 11. The apparatus of claim 6, further comprising:
 2 an elevator to transfer said substrate from said stripping line to said
 3 cleaning line.
 - 12. The apparatus of claim 6, further comprising:

- a loader for loading the substrate to the etching line; and
- a unloader for unloading the substrate from the cleaning line.
- 1 13. The apparatus of claim 12, wherein said loader includes at least
- one of a conveyor and a robot.
- 14. The apparatus of claim 12, wherein said unloader includes at least
- one of a conveyor and a robot.